

Notice of References Cited

Application/Control No.

09/207,546

Applicant(s)/Patent Under
Reexamination
DEGENDT ET AL.

Examiner

Shamim Ahmed

Art Unit

1746

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
	A	US-5466389	11-1995	Ilardi et al	252	156
	B	US-3871929	03-1975	Schevey et al	216	83
	C	US-				
	D	US-				
	E	US-				
	F	US-				
	G	US-				
	H	US-				
	I	US-				
	J	US-				
	K	US-				
	L	US-				
	M	US-				

FOREIGN PATENT DOCUMENTS

*		Document Number	Date	Country	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY				
	N						
	O						
	P						
	Q						
	R						
	S						
	T						

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	Kern, Werner, "Hand Book of Semiconductor Wafer Cleaning Technology", 1993,p. 599-601.					
	V						
	W						
	X						

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.